

Patent PCT/JP2004/016839
Attorney Docket 4439

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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)	Art Unit (not assigned)
Application No.:	(not assigned))	
)	Int'l. Application No.
Filed:	(not assigned))	PCT/JP2004/016839
)	
For:	VACUUM EVAPORATION DEPOSITION)	
	METHOD OF THE WINDING TYPE AND)	
	VACUUM EVAPORATION DEPOSITION)	
	APPARATUS OF THE SAME)	
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PRELIMINARY AMENDMENT

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Sir:

Kindly enter the following preliminary amendments to the claims, specification, abstract
and drawings as indicated hereinafter.